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JENKINS
WILSON
& TAYLOR,

patent attorney

October 11, 2005

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 11, 2005.

Gayle W. Chaney
Gayle W. Chaney
Date of Signature: 10/11/05

RICHARD E. JENKINS

JEFFREY L. WILSON

ARLES A. TAYLOR, JR.

GREGORY A. HUNT

E. ERIC MILLS

BENTLEY J. OLIVE

*CHRIS PERKINS, PH.D.

**JAMES DALY IV, PH.D.

JEFFREY CHILDERS, PH.D.

P. ASHLEY DARDEN

CHRISTOPHER B. LEE

TECHNICAL SPECIALIST

AMY ODENBAUGH, PH.D.

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: U.S. Patent Application Serial No. 10/801,781 for
PROCESS FOR PRODUCING AN ETCHING MASK ON A
MICROSTRUCTURE, IN PARTICULAR A SEMICONDUCTOR
STRUCTURE WITH TRENCH CAPACITORS, AND
CORRESPONDING USE OF THE ETCHING MASK
Our Ref. No. 1406/189

Sir:

Please find enclosed in connection with the subject U.S. patent application the following documents:

1. An Amendment A with Replacement Abstract; and
2. A return-receipt postcard to be returned to us with the U.S. Patent and Trademark Office filing stamp thereon.

The Commissioner is hereby authorized to charge any fees associated with the filing of this correspondence to Deposit Account Number 50-0426.

Respectfully submitted,

JENKINS, WILSON & TAYLOR, P.A.

Richard E. Jenkins
Richard E. Jenkins
Registration No. 28,428

REJ/gwc

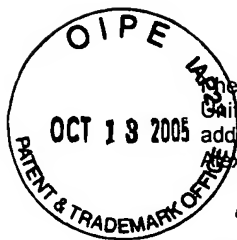
Enclosures

Customer No: 25297

tel 919.493.8000
fax 919.419.0383

Jenkins, Wilson & Taylor, P.A.
JenkinsWilsonTaylor.com

University Tower, Suite 1400 | 3100 Tower Boulevard | Durham, North Carolina 27707



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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Moll et al.

Group Art Unit: 2891

Serial No.: 10/801,781

Examiner: Chandra P. Chaudhari

Filed: March 16, 2004

Docket No.: 1406/189

Confirmation No.: 3095

For: PROCESS FOR PRODUCING AN ETCHING MASK ON A MICROSTRUCTURE,
IN PARTICULAR A SEMICONDUCTOR STRUCTURE WITH TRENCH
CAPACITORS, AND CORRESPONDING USE OF THE ETCHING MASK

AMENDMENT A

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is responsive to the Office Action Summary dated September 19, 2005, for which a shortened statutory period for reply is set to expire on November 19, 2005. Favorable consideration is respectfully requested in view of the following Amendments and Remarks.